

<b>Notice of References Cited</b>	Application/Control No. 10/568,128		Applicant(s)/Patent Under Reexamination ODAKE ET AL.	
	Examiner Tina M. Wong		Art Unit 2874	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2002/0196385	12-2002	He et al.	349/61
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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